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	L34	linkage and L33	603
	L33	support and sensor and L32	4637
	L32	robot and sensor and substrate	6630
	L31	robot and sensor and substrate spport	0
	L30	correct\$3 and position and sensor and substrate spport	0
	L29	(correct\$3 and position and sensor) and substrate spport	0
	L28	(correct\$3 and position and sensor) same substrate spport	0
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	L26	(correct\$3 and positoin) same substrate spport and sensor	0
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	L24	correct\$3 and L23	19
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	L22	robot and L21	52
	L21	bacchi.in.	171
	L20	bacchi.in. and substrate and sensor	0
	L19	bacchi.in. and substrate and sensor and motor	0
	L18	bacchi.in. and substrate and sensor and motor and displacement	0
	L17	bacchi.in. and substrate and sensor and motor and displacement and correct\$3	0
	L16	bacchi.in. and substrate and sensor and motor and displacement and correct\$3 and position	0
	L15	bacchi.in. and substrate and sensor and motor and displacement and correct\$3 and position and central axis	0
	L14	bacchi.in. and substrate and sensor and motor and displacement and correct\$3 adn position and axis	0
	L13	bacchi.in. and substrate and sensor and motor and displacement and correct\$3 adn position and central axis	0
	L12	L8 and L9	73
	L11	L8 and L9 and L10	26
	L10	central axis and L9	49563
	L9	predetermin\$3 or "pre-defin\$3" and L8	2638309
	L8	support and L7	77
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	L6	L4 and L5	111

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	1543
robot and motor and control\$3 and substrate and sensor and position and optical and capacitor and magnetic	222
L3 bacchi.in.	171
☐ L2 yim.in. and robot and substrate	10
□ L1 10/697731	1

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"substrate support" robot displacement correct Search.

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<u>Detection system for substrate clamp - Patent 6313596</u>

A substrate support member for a robot operable in a semiconductor processing ... 16, the displacement distances of the second and third substrates 114, ...

www.freepatentsonline.com/6313596.html - 68k - Cached - Similar pages

Detection system for substrate clamp - Patent 6166509

(c) a **substrate support** member movable through the enclosure. comprising: ... incremental displacement of the support member 66 caused by the robot 62. ...

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SMD placement: Turning concepts into output :: EM ASIA is the ...

After picking, each robot will move the component to the correct ... Feeder index movement limitations (depending on displacement between 2 feeders needed ...

www.emasiamag.com/article.asp?articleid=164 - Similar pages

EP1465012 Asml european software patent - Supporting structure for ...

The supporting structure may be a robot (8). The robot (8) has a robot arm (10) with a ... The robot arm comprises one or more compliant parts (14; 26;

gauss.ffii.org/PatentView/EP1465012 - 71k - Cached - Similar pages

[PDF] Derwent

File Format: PDF/Adobe Acrobat - View as HTML

surface of substrate support chuck, used to support a substrate within a ... displacement of wafer (W) with respect to both surfaces is measured by ... scientific.thomson.com/ts/ media/dw/productpdfs/itppdfs/itsetes.pdf -Similar pages

SPIE Proceedings Vol. 2871

The basic components of 2dF are the corrector lens optics, the robot which ... This effect became apparent when this system was applied to correct the ...

www.spie.org/web/abstracts/2800/2871.html - 90k - Cached - Similar pages

United States Patent: 6571657

The substrate support pins 906 preferably comprise distally tapered members ... Robot blades 3508, 3510, and 3512 are then adjusted by displacement of the ...

patft.uspto.gov/netacgi/nph-Parser?Sect2=PTO1&

Sect2=HITOFF&p=1&u=%2Fnetahtml%2Fsearch-bool.ht... - 195k -

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United States Patent: 5377002

For unambiguous identification of the correct positioning of the lens after it is ... A handling robot 105 is placed between the wafer cassettes 109, 110.

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<u>Lithographic support structure patent invention</u>

[0079] By providing the **robot** arm 10 with at least one of the compliant parts 14, 26, a tilt and/or a displacement in z between the substrate W and another ...

www.freshpatents.com/ Lithographic-support-structuredt20041209ptan20040246459.php - 102k - Cached - Similar pages

DoD_SBIR FY01.2 - SOLICITATION SELECTIONS w/ ABSTRACTS

However, without the **correct** fluid handling systems and electrode placement physical ... PackBot is an extremely robust tracked robot with allweather and ...

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